



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q67940

Masaki KURIHARA, et al.

Appln. No.: 10/035,137

Group Art Unit: 1752

Confirmation No.: 3139

Examiner: John Chu

Filed: January 04, 2002

For: POSITIVE PHOTORESIST COMPOSITION

REQUEST FOR RECONSIDERATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated December 11, 2003, once extended from March 11, 2004 to April 12, 2004 (April 11, 2004 being a Sunday) by the filing of an appropriate Petition and payment for an extension of time submitted herewith, please consider the following remarks.

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